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## AMENDMENTS TO THE CLAIMS

The following Listing of Claims replaces all prior versions, and listings, of claims in the present application.

Listing of Claims

1-10. (Canceled).

11. (Previously presented) A method of forming a nozzle plate for droplet deposition apparatus, the nozzle plate defining a nozzle plate plane and comprising a plate having at least one nozzle plate layer and a plurality of nozzles, each nozzle extending through polymeric material located within a respective aperture within the nozzle plate, the method including the steps of defining a plurality of distinct bodies of polymeric material distributed over the nozzle plate plane, each said body having a periphery, and subsequently forming at least one metal nozzle plate layer by electroforming around said peripheries of said bodies of polymeric material so as to define at least in part the shapes of said apertures.

12-17 (Canceled).

18. (Previously presented). A method of forming a nozzle plate component for a droplet deposition apparatus, said method comprising the steps of:

forming a layer of first photoresist material on a substrate;

subsequently selectively exposing and removing first photoresist material to define on the substrate an array of distinct bodies of said first photoresist material;

subsequent to said step of selectively exposing and removing first photoresist material, forming a first plate of metal around said bodies, so as to form a metal nozzle plate having apertures, each aperture containing one of said bodies of said first photoresist material; and then forming a nozzle extending through each body of said first photoresist material.

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Amendment dated May 3, 2010

Reply to Notice of Non-Compliant Amendment mailed April 2, 2010

19 (Original). A method according to Claim 18, further comprising the step of depositing a

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metallic layer on the substrate prior to forming of the layer of first photoresist material, said

first plate of metal being electroformed with said metallic layer serving as a seed layer.

20-21 (Canceled).

22 (Previously presented). A method according to claim 11, wherein said nozzles are formed by

ablating through said bodies.

23 (Previously presented). A method according to claim 18, wherein said nozzles are formed by

ablating through said bodies.

24 (New). Method of forming a nozzle plate component for a droplet deposition apparatus,

said method comprising the steps of:

forming a body of a first material said body having a periphery,

subsequently forming a plate of second material around said body such that the plate

extends around at least a portion of said periphery of said body of said first material; and

forming a nozzle extending through said body of said first material.

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